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APPLICANT
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Article entitled Heavy p-doping of ZnTe by molecular beam epitaxy using a nitrogen plasma source, Appl. Phys. Lett. 62 (8), 22 February 1993, Copyright 1993 American Institute of Physics

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